



501.41125X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. HIROI, et al  
Serial No.: 10/062,666  
Filed: February 5, 2002  
For: PATTERN INSPECTION METHOD AND  
SYSTEM THEREFOR  
Group: 2881  
Examiner: J. Berman

**AMENDMENT AFTER FINAL REJECTION**

Mail Stop: Box AF Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 18, 2006

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the office action dated September 18, 2006, as listed below and as set forth on the following pages:

Amendments to the Specification;  
Amendment of the Claims; and  
Remarks are included following the amendments.